



ELECTRONIC COPY

LG794657026
Report verification at igi.org



April 22, 2026

IGI Report Number **LG794657026**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **8.14 X 5.43 X 3.49 MM**

GRADING RESULTS

Carat Weight **1.00 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

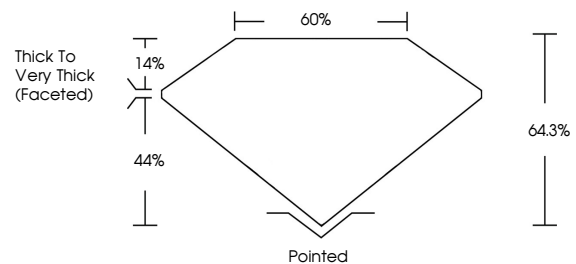
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG794657026**

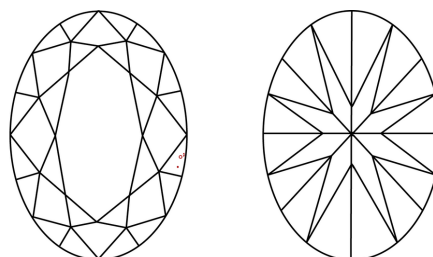
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

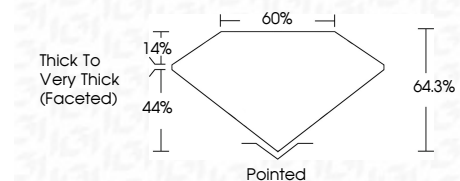
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI



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IGI Report No LG794657026
OVAL BRILLIANT
8.14 X 5.43 X 3.49 MM
1.00 CARAT
E
Color Grade
Clarity Grade VS 1
Depth 64.3%
Table 60%
Girdle Thick to Very Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG794657026

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